## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Lui Guo LIN

Appl. No: 10/023,739

Confirmation No: 4207

Filed: December 21, 2001

For: STRUCTURE OF

SEMICONDUCTOR ELECTRONIC

DEVICE AND METHOD OF MANUFACTURING THE SAME Art Unit: 2812

Examiner: UNKNOWN

Atty. Docket No: 32014-177429

Customer No:

## **Information Disclosure Statement**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is an Information Disclosure Statement submitted under 37 C.F.R. § 1.97 within the time specified under 37 C.F.R. § 1.97(b).

In order to comply the duty of disclosure pursuant to 37 C.F.R. § 1.56, submitted herewith is a form PTO/SB/08A listing the documents to be considered by the Examiner. A copy of each of the listed documents is enclosed.

Cite Nos. A2 and A3 were cited in an Office Action issued by the Japanese Patent Office in a corresponding Japanese application. A copy of the Action from the Japanese Patent Office is attached. Cite No. A1 is a U.S. Patent Application Publication corresponding to Cite No. A2. An English language translation of Cite No. A3 is attached.

The present Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits, and therefore no Statement Under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required.

In view of the above, no further translation or statement of relevance is required, and

as all requirements of 37 C.F.R. § 1.97 and all official guide lines pertaining to Information Disclosure Statements have been complied with, and it is therefore respectfully requested that the Examiner consider the documents and make them of record.

Please charge any necessary fee or credit any overpayment in connection with this Information Disclosure Statement to Deposit Account No. 22-0261.

Date: 06/11/03

Respectfully submitted,

Chad C. Anderson Registration No. 44,505

VENABLE P.O. Box 34385

Washington, D.C. 20043-9998

Telephone: (202) 962-4800 Telefax: (202) 962-8300

CCA/trl DC2-463140 Attorney Docket Number

32014-177429

U.S. PATENT DOCUMENTS							
Examiner initials *	Cite No.1	U.S. Patent Document		Name of Patentee or Applicant of Cited Document  Jeong-Hwan SON	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
						<del>                                     </del>	
	<del> </del>					1	
	-					REC	
	<del>                                     </del>					1 - C	
						C 3	
			-			2100	
						70	
						80	
						0	
						,	
			i				

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cita	Foreign Patent Document			Name of Patentee	Date of Publication of	Pages, Columns, Lines,	
	Cite No. <sup>1</sup>	Office <sup>3</sup>		nd Code <sup>5</sup> f known)	or Applicant of Cited Document	Cited Document MM-DD-YYYY	Where Relevant Passages or Relevant Figures Appear	T <sub>6</sub>
	A2	JР	10-163491			06-19-1988		
	A3	JР	11-274488			10-08-1999		
		<del> </del>						

Examiner Signature	Date Considered	

SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.

VENABLE

Sheet

of 1

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.